RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITED PROCEDURE EXAMINING GROUP 1700

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Smith, et al.

Docket No.:

2001 P 11900 US01

aeceived

Serial No.:

10/786,996

Art Unit:

1746

444

Filed:

February 25, 2004

Examiner:

Markoff, Alexander

JUL 14 2006

For:

Method of Removing PECVD Residues of Fluorinated Plasma Using In-

Situ H₂ Plasma

Mail Stop: After Final Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 CFR § 1.116

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated May 17, 2006, which Action is made final.

Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of claim 8.